

Notice of References Cited	Application/Control No. 10/735,771		Applicant(s)/Patent Under Reexamination HONGO ET AL.	
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U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2005/0034999	02-2005	Lee et al.	205/640
*	B	US-6,352,469	03-2002	Miyazaki et al.	451/67
*	C	US-6,852,630	02-2005	Basol et al.	438/691
*	D	US-6,942,780	09-2005	Basol et al.	205/137
*	E	US-6,554,205	04-2003	Shinozuka et al.	239/120
*	F	US-2002/0148732	10-2002	Emesh et al.	205/117
*	G	US-6,811,680	11-2004	Chen et al.	205/662
*	H	US-2004/0154931	08-2004	Hongo et al.	205/676
*	I	US-4,663,004	05-1987	Switzer, Jay A.	205/103
*	J	US-6,923,892	08-2005	Tatsuura et al.	204/224R
*	K	US-2003/0181141	09-2003	Taniguchi et al.	451/36
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
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	Q					
	R					
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	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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